







SMR.1670 - 31

INTRODUCTION TO MICROFLUIDICS

8 - 26 August 2005

Chip-based GC

H. Gardeniers University of Twente, Enschede, The Netherlands



Chip-based GC

Han Gardeniers MESA+ Institute for Nanotechnology University of Twente

Summer School in Microfluidics ICTP, Trieste, Italy





to identify and measure chemicals in Titan's atmosphere During descent, the GCMS analyzes pyrolysis products (i.e., samples altered by heating) passed to it from the Aerosol Collector Pyrolyser. Finally, the GCMS measures the composition of Titan's surface, by heating the GCMS

instrument just prior to impact in order to vaporize the surface material upon contact

http://www.esa.int/SPECIALS/Cassini-Huygens

Cassini-Huygens GCMS



GCMS overview and some components



capillary separation column





The enrichment cell (right) is a separate instrument that uses the MS detector to analyze its samples. It is essentially a small container coated with carbon absorber on which organic components will collect. Whatever compounds do not stick to the enrichment cell pass into a rare gas cell



source: http://huygensgcms.gsfc.nasa.gov/

Why small GC's?

Table 1. Classification of portable chromatographs

Туре	Purpose	Advantages, capabilities
Compact	For mobile and stationary laboratories	Saving of costs, power, materials, and space with analytical characteristics similar to those of stationary chromatographs, weight 10–25 kg
Portable, transportable, field	For on-site analysis	Small weight, rapid analysis, gas and power self-supporting, weight 5–15 kg
Chip-based chromatographs (sili- con micromachining technology), handheld, personal, pocket	For on-site analysis, handheld	For the fast resolution of relatively simple analytical problems, fully self-supporting, restricted analytical capabilities, weight 0.2–3 kg
Specially designed chromato- graphs, micro chromatographs	For space investigations	Automated analysis, small weight, resistant to impact and shaking



from: Yashin e.a. J.Anal.Chem. 56, 794-805 (2001) -mainly Russian developments



University of Twente



GC instrumentation

GC in the ol'days



Gas chromatograph of the late 1950's





Fatty acid gas chromatogram (1951)

Lunar Gas Chromatograph designed in 1962.

1941: Gas chromatography mentioned by Martin and Synge in paper on liquid chromatography (1) 1951: Martin and James publish first gas chromatograph (2) 1979: Dandeneau developes polymer-coated fused silica capillary (3)

1. A.J.P. Martin and R.L.M. Synge, Biochem. J. 35, 1358 (1941)

2. A.T. James and A.J.P. Martin, Biochem. J. 50, 679 (1952) 3. R.D. Dandeneau and E.H. Zerenner, High Res.Chrom.&Chrom.Commun. 2(6), 351–356 (1979)



http://www.chromatography-online.org/GC/ http://www.quadrexcorp.com/new/history.htm







Modern injectors





source: http://www.chromatography-online.org/GC/



Injection procedures to reduce plug width





Retention Gap Method of Sampling

Solute Focusing Method sampling

The injector is designed such that there are two consecutive, independently heated and cooled zones located at the beginning of the column.



Different stationary coatings and coating procedures



Temperature programming



Slowly ramping T throughout the separation provides a basis for the separation of sample components based on boiling point.

Comparison of of isothermal (top) and programmed temperature chromatography. Column: 1.6 mm ID and 6 m long, containing 3% Apiezon L (liquid phase) on 100/120 mesh VarAport 30 solid support. He flow rate 10 ml/min. Detector sensitivity in top graph is 16 times that of bottom.



H.M. Mcnair and E.J. Boneli, Basic gas chromatography, Palo Alto, CA, Varian Istrument Div. 1968







Gas Chromatography Detector Overview

Electron capture







Flame detector overview





Flame photometric detector



http://www.chromatography-online.org/GC/ & http://ull.chemistry.uakron.edu/chemsep/





<u>Thermal Conductivity Detector</u> <u>or "Katherometer"</u>





http://www.chromatography-online.org/GC/



Comparison FID and TCD







Sensitivity of different detection methods





http://ull.chemistry.uakron.edu/chemsep/

University of Twente

Hyphenated GC



2-D GC relies on passing a portion of effluent to a second column using flow switching







Comprehensive 2-D gas chromatography











Gas Chromatograph Miniaturisation

GC basics: open-tubular column

Revisit the (classic) van Deemter equation (no A-term):

$$H = \frac{B}{u} + (c_m + c_s)u$$

with $B = 2D_m$ (~ axial diffusion)

$$C_m = \frac{4(1+9k+25.5k^2)z_0^2}{105(1+k)^2 D_m} \text{ and } C_s = \frac{2k^3 z_0^2}{3(1+k)^2 K^2 D_s}$$

 C_s and C_m can be regarded as mass transfer resistances of the analyte in the stationary phase (e.g. a liquid film) and the mobile phase (the carrier gas), i.e. ~ radial diffusion

 z_0 : half column height D_m , D_s : diffusivities in m and s phases, resp.

k: partition ratio (depends on z₀) K: partition coefficient





Miniaturized open-tubular GC

Generally, the C_s term dominates over C_m (thin film of stationary phase), and even more so in miniaturised columns.

In first order, a smaller column diameter leads to lower H (=better performance) But smaller diameter also means: higher pressure drop!



Advantage of narrow-bore columns





The first GC on a chip



Separately fabricated TCD chip was mounted at outlet

Integrated micromachined membrane valves 1.5 m long column

Low performance due to non-uniform liquid stationary phase



Terry e.a. IEEE Tr. Electron. Dev. ED-26, 1880-1886 (1979) PhD thesis Terry, 1975, Stanford University



Improved GC chip design



From US patent 4,471,647 "Gas chromatography systems and detector and method", issued Sep.18, 1984, by Jerman and Terry



Alternative ways to coat in a chip



Plasma polymerised layer as stationary phase is applied in a reactive-ion etched trench in silicon before anodic bonding to Pyrex



romatogram of several arkanes

http://www.tu-harburg.de/mst/english/forschung/gc.shtml



Hsieh e.a. Sens.Act.B 82, 287-296 (2002)

University of Twente

Silicon micromachined GC ...



 $0.2 \ \mu m \ \alpha$ -phase Cu-phtalocyanine coating was sublimed on Si and Pyrex surfaces before anodic bonding; column was 0.9 m long, 300 μm wide and 10 μm deep



MESA



... with integrated detectors



Si double-GC with integrated valves...







Miniaturized flame ionization and AES detector for gas chromatography



MESA⁺

Zimmermann e.a. Sens.Act.B 63, 159-166 (2000) & 83, 285-289 (2002)

Double plasma GC injector and detector



Stop-flow programmable selectivity with a dualcolumn ensemble





Lambertus e.a. Anal.Chem. 76, 2629-2637 (2004) & 77, 2078-2084 (2005)



Micromachined GC for clinical diagnostics



Gas sensor for micro-GC



Suspended membrane with microheater, temperature sensor and interdigitated microelectrode covered by a SnO₂-based sensitive layer





Lorenzelli e.a. Biosens.Bioel. 20, 1968-1976 (2005)

University of Twente

Preconcentrator-focuser for GC









Microheater with Carbopack X adsorbent granules loaded between the heating elements

Preconcentration factors as high as 5600 and desorbed peak widths as narrow as 0.8 s are achieved from 0.25-L samples of benzene at modest heating rates.



Tian e.a. J.MEMS 12, 264-272 (2003)





University of Twente



µChemLab[™] project at Sandia





For an overview see: D.Lindner, Lab Chip 1, 15N-19N (2001)



Concept of GC-based mChemLabTM











@ preconcentrator



gas chromatograph



acoustic mass detector









Silicon micromachined injectors



left: older format; right: format used in Varian CP-4900 micro-GC injector info: www.xensor.nl/txtfiles/ projects/xi-proj/injec.htm

Right: micromachined GC-column (replacable) Left: 200 nl detection volume TCD

From Varian micro-GC brochure









A new definition of process gas chromatography



Slide courtesy of Arno Steckenborn, Siemens, Germany

Injection step 1: fill loop



Advantages:

- Narrow start peak width
- Sample equilibrated to carrier gas pressure level (sample pressure independent)
- Injection volume adjustable by time
- Injection quality does no longer depend on valve quality
- Tolerance against quality and even leakage of the sample valve





Injection step 2: flow to injector



Injection step 3: split of slice





University of Twente



Micro TCD







Analyzer Module



<u>MESA</u>+

Slide courtesy of Arno Steckenborn, Siemens, Germany

